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hereby certify that this paper and the documents enclosed herewith are being deposited on the date ed below with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

Date: December 6, 2005

Jonathan A. Platt

Docket No. H1547

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Inventor:

Tabery, et al.

Art Unit:

1756

Serial No.:

10/791,259

Examiner:

Not yet assigned

Filing Date: March 2, 2004

Title:

LITHOGRAPHY MASK UTILIZING ASYMMETRIC LIGHT SOURCE

STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The above-identified application has been on file since March 2, 2004. The applicant respectfully inquires as to when the application will be taken up for examination.

A prompt reply to this inquiry would be appreciated.

Respectfully submitted,

RENNER, OTTO, BOISSELLE & SKLAR, LLP

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